



































	Current Interconnect Densities Intel Pentium-III, 0.18 μ m, 6 aluminum layers, SiOF dielectric (ϵ_r = 3.1)			
■ Int die				
	Metal Layer	Pitch (μm)	Aspect Ratio	
			(Height/Width)	
	M1	0.50	1.9	
	M2	0.64	2.2	
	M3	0.64	2.2	
	M4	1.08	2.0	
	M5	1.60	2.0	
	M6	1 76	2.0	

6.893: Advanced VLSI Computer Architecture, September 12, 2000, Lecture 2, Slide 19. © Krste Asanović





